

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>	Docket Number (Optional) <b>3839</b>	Application Number <b>10/594,284</b>
	Applicant(s) <b>WITZMANN, A., ET AL</b>	
	Filing Date <b>09/26/2006</b>	Group Art Unit

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6,064,034	05/16/2000	RIECK			

**U.S. PATENT APPLICATION PUBLICATIONS**

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

**OTHER DOCUMENTS** *(Including Author, Title, Date, Pertinent Pages, Etc.)*

		D1, WANG, AIHUA "PRESENT STATUS AND PROSPECT OF LASER SURFACE MODIFICATION OF REFRACTORY MATERIALS." LASER TECHNOLOGY, JUNE 2002, PAGES 413-418.
		D2, "REFRACTORY MATERIAL USED FOR FUSED FURANCE OF WASTE." FOREIGN REFRACTORIES, FEBRUARY 2004VOL. 29, NO. 1, PAGES 10-15.

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.